Examiner-Initiated Interview Summary	Application No.	Applicant(s)		
	10/595,862	LEUSSLER ET AL.		
	Examiner	Art Unit		
	Tiffany A. Fetzner	2831		
All Participants: Status of Application: <u>Amended</u>				
(1) <u>Tiffany A. Fetzner</u> .	) <u>Tiffany A. Fetzner</u> . (3)			
(2) <u>Attorney Thomas E. Kocovsky Jr. Reg. No. 28,383</u> . (4)				
Date of Interview: <u>17 December 2008</u> Time: <u>2:50 p.m.</u>				
Type of Interview:  ☐ Telephonic ☐ Video Conference ☐ Personal (Copy given to: ☐ Applicant ☐ Applicant's representative)  Exhibit Shown or Demonstrated: ☐ Yes ☐ No If Yes, provide a brief description:				
Part I.				
Rejection(s) discussed: None				
Claims discussed: Independent claim 1.				
Prior art documents discussed:  Hayes US patent 6,888,153, and pays patent application publication 2001/0035504A1 with respect to figure 1.				
Part II.				
SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:  The Examiner contacted applicants representative to request permission to make an examiner's amendment to independent claim one, in order to clarify the locational novelty of applicants parallel RF shield and remove intended use concerns. The Ex. was given permission to do the examiner's amendment and thanked for her time in moving the application forward towards allowance.				
Part III.				
<ul> <li>It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.</li> <li>It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.</li> </ul>				
/T. A. F./ Examiner, Art Unit 2831 (A	pplicant/Applicant's Representati	ive Signature – if ap	ppropriate)	